

IN THE CLAIMS

Please amended claims as follows.

Please replace the pending claims with the following claims:

1-17. Cancelled.

18. (Currently amended) A refurbished component for a process chamber, the component comprising a titanium structure having a refurbished textured titanium coating over an intermetallic compound, wherein the component is refurbished by the steps of:

(i) immersing the component in a cleaning solution to remove an original titanium coating to expose an intermetallic compound on the titanium structure of the component;

(ii) removing the intermetallic compound by bead blasting with blasting beads having a bead diameter of less than about 180 micrometers propelled by a gas pressurized to a pressure of less than about 310 kPa to form an exposed surface of the structure;

(iii) texturizing the exposed surface of the titanium structure by bead blasting with blasting beads having a bead diameter of less than about 1000 micrometers that are propelled by a gas pressurized to a pressure of less than about 414 kPa, to form a textured surface having a surface roughness average of from about 3.81 micrometers to about 8.89 micrometers; and

(iv) forming the refurbished titanium coating on the textured surface by twin-wire arc spray coating,

whereby the refurbished component is capable of being refurbished by the method at least about 15 times substantially without failure of the component.

19. (Currently amended) A component according to claim 18 wherein the component comprises at least a portion of ~~one or more of~~ an enclosure wall, a chamber shield, a target, a cover ring, a deposition ring, a support ring, an insulator ring, a coil, a coil support, a shutter disk, clamp shield ~~and a~~ or substrate support.

20. (Currently amended) A substrate processing chamber component comprising:

(a) a titanium structure comprising at least a portion of an enclosure wall, chamber shield, cover ring or deposition ring; and

(b) a titanium coating over the structure, the titanium coating having a textured surface.

21-22. Cancelled.

23. (Previously presented) A component according to claim 20 wherein the titanium coating comprises a twin-wire arc sprayed titanium coating.

24. (Currently amended) A substrate processing chamber component comprising:

(a) a structure made from titanium, the titanium structure comprising at least a portion of an enclosure wall, chamber shield, cover ring or deposition ring; and

(b) a titanium coating over the titanium structure, the titanium coating having a textured surface.

25. Cancelled.

26. (Previously presented) A component according to claim 24 wherein the titanium coating comprises a twin-wire arc sprayed titanium coating.

27. (Previously presented) A component according to claim 18 wherein the intermetallic compound comprises at least one of aluminum, titanium, stainless steel, copper and tantalum.

28. (Previously presented) A component according to claim 18 wherein in (i) the cleaning solution comprises an acidic or basic solution to dissolve the titanium coating.

29. (Previously presented) A component according to claim 18 wherein in (i) the cleaning solution comprises HF and HNO₃.

30. (Previously presented) A component according to claim 18 wherein (ii) comprises bead blasting the intermetallic compound with blasting beads having a bead diameter greater than about 80 micrometers.

31. (Previously presented) A component according to claim 18 wherein (ii) comprises bead blasting the intermetallic compound by propelling blasting beads towards the intermetallic compound with a gas that is pressurized to a pressure of greater than about 172 kPa.

32. (Previously presented) A component according to claim 18 wherein in (iii) the texturizing bead blasting step comprises propelling blasting beads having a bead diameter of greater than about 400 micrometers at the exposed surface of the structure with gas that is pressurized to a pressure of at least about 276 kPa.

33. (Previously presented) A component according to claim 18 wherein the exposed surface of the structure comprises crevices, and wherein the bead diameter is selected to be smaller than the average width of the crevices, whereby the blasting beads can penetrate into the crevices to remove the intermetallic material.

34. (Previously presented) A component according to claim 18 wherein (iv) comprises generating an electrical arc that at least partially liquefies a titanium coating material, and passing a pressurized gas past the liquefied titanium coating material to propel the liquefied coating material towards the textured surface.

35. (Currently amended) A substrate processing chamber component comprising:

(a) a structure made from titanium, the titanium structure comprising at least a portion of an enclosure wall, chamber shield, cover ring or deposition ring; and

(b) a titanium coating over the titanium structure, the titanium coating ~~comprises~~ comprising a twin-wire arc sprayed titanium coating having a textured surface.

36. (Currently amended) A component according to claim 35 wherein the titanium structure comprises at least a portion of one or more of an enclosure wall, a chamber shield, a cover ring and a deposition ring.

37. (Currently amended) A substrate processing chamber component comprising:

(a) a titanium structure comprising at least a portion of ~~one or more of~~ an enclosure wall, a chamber shield, a cover ring ~~and a~~ or deposition ring; and

(b) a titanium coating over the structure, the titanium coating having a textured surface.

38. Cancelled.